Rapid Communications

Defects in Cd₃As₂ epilayers via molecular beam epitaxy and strategies for reducing them

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(Received 3 September 2019; revised manuscript received 5 November 2019; published 9 December 2019)

Molecular beam epitaxy offers an exciting avenue for investigating the behavior of the topological semimetal Cd_3As_2 , by providing routes for doping, alloying, strain engineering, and heterostructure formation. To date, however, minimal exploration has been devoted to the impact of defects that are incorporated into epilayers due to constraints imposed by the substrate and narrow growth window. Here, we use a combination of lattice-matched $Zn_xCd_{1-x}Te$ buffer layers, miscut substrates, and broadband illumination to study how dislocations, twins, and point defects influence the electron mobility of Cd_3As_2 . A combination of defect suppression approaches produces Cd_3As_2 epilayers with electron mobilities upwards of 15 000 cm²/Vs at room temperature.

DOI: 10.1103/PhysRevMaterials.3.121201

I. INTRODUCTION

Topological semimetals provide rich systems in which to explore new and interesting physics [1,2]. Their symmetry-protected band-touching nodes with linear dispersions can host relativistic massless electrons at the Fermi level and support an array of transport behaviors not typically observed in trivial semiconductors or metals. Recent experimental investigations in Dirac and Weyl semimetals have demonstrated evidence for Fermi arcs [3], the quantum Hall effect [4], and giant magnetoresistance [5]. These breakthroughs will undoubtedly form the basis for future technologies, such as low-dissipation electronics and novel spintronics [6].

In parallel to these discovery efforts, it is critically important to develop the topological semimetal materials themselves. High-quality crystals in bulk, epitaxial layer, and nanostructure forms are necessary to enable future progress on both scientific and technological fronts. The Dirac semimetal Cd_3As_2 is a primary example [2]. Although many of the initial band-structure and transport physics have been carried out in bulk single crystals [5,7], synthesis in epitaxial layers allows us to study the roles of confinement, strain [8], and heterostructures on their properties as well as fabricate them into devices.

Two factors strongly influence epitaxial growth of Cd_3As_2 and its resulting properties. The first is the substrate. Cd_3As_2 has a tetragonal crystal structure at temperatures $<475\,^{\circ}C$ with a $I4_1/acd$ space group and lattice parameters $a=1.263\,\mathrm{nm}$ and $c=2.543\,\mathrm{nm}$ [9]. The atomic arrangement of its preferred (112) growth plane mirrors that of the (111) plane of zinc-blende crystals [10]. Coincident atomic arrangements between the two can be achieved when the lattice constant of the zinc-blende crystal is between those of ZnTe and CdTe. Previous growth on GaSb and CdTe substrates indicates that careful control of extended defects is necessary to achieve high electron mobilities [10,11]. Additionally, II-VI alloy

substrates offer advantages over III-V's due to their higher band gaps, which limit them from introducing parallel conduction channels. The second factor influencing epitaxy is the relatively narrow window of growth parameters that can be accessed. The high vapor pressure of Cd₃As₂ in vacuum practically restricts growth to temperatures below 250 °C, limiting the grower's ability to control surface morphology and defect formation. Even lower temperatures $\ll 200$ °C are necessary to maintain reasonable growth rates without loss to reevaporation. In this context, approaches are needed to reduce point and extended defects generated as a result of heteroepitaxy or the use of low growth temperatures to realize high-quality epitaxial structures that will enable future scientific and technological advances.

Here, we present a framework for Cd₃As₂ growth by molecular beam epitaxy (MBE) using elemental sources and lattice-engineered II-VI buffer structures. Relaxed $Zn_{1-x}Cd_x$ Te buffer layers on miscut GaAs(111) substrates spanning the entire solid solution provide a platform to control extended defects and strain conditions. Growth of Cd₃As₂ from elemental sources, allowing for flexibility in stoichiometry and defect control, is then demonstrated on these buffer structures. Finally, broadband light stimulation is explored as a route to further improve the electron mobility in Cd₃As₂ epilayers while maintaining low substrate temperatures. This Rapid Communication systematically explores the impact of each approach on the electron mobility as well as the interplay between them. We find that the combination of all three approaches ultimately improves the electron mobility and maximizes flexibility in designing the growth conditions of Cd₃As₂ epilayers, alloys, and heterostructures for a variety of investigations.

II. EXPERIMENTAL METHODS

Epilayers were grown in an interconnected, dual chamber Omicron EVO25 MBE system. All group II, III, and VI sources were evaporated from effusion cells, while As_4 was

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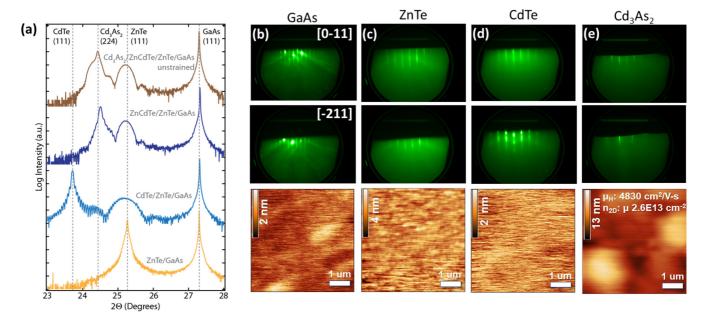


FIG. 1. (a) XRD of Zn_xCd_{1-x} Te/ZnTe/GaAs buffer structures as well as an unstrained Zn_xCd_{1-x} Te/ZnTe/GaAs buffer structures as well as an unstrained Zn_xCd_{1-x} Te/ZnTe/GaAs structure. All GaAs substrate orientations were on axis.

evaporated from cracker sources in both chambers. Substrate temperatures were calibrated using a k-space band-edge thermometry system. Oxide removal of GaAs(111) under As₄ was performed in a dedicated III-V chamber followed by growth of a 300-nm GaAs buffer layer at high temperatures $(>610\,^{\circ}\text{C})$ and low V/III ratios (3–5:1) [12]. The substrates were then cooled down and capped with an arsenic film. Samples were subsequently removed from vacuum and reloaded on Mo blocks specific to the II-VI chamber to minimize contamination. The arsenic cap was thermally desorbed at \sim 350 °C, and the substrate was cooled down to commence II-VI and II-V growths. Specific growth conditions are described below. Unless noted, the sample surface was illuminated with broadband light from a Xe lamp (Oriel 6255) during growth of both the II-V buffer and Cd₃As₂ epilayers. The lamp powers are stated below. Hall measurements were performed at room temperature using annealed indium contacts and van der Pauw geometry under excitation voltages of 5 mV (50–200 μ A). Multiple samples were measured for each growth condition to produce the mobility ranges reported in the Results section. Electron-channeling contrast imaging (ECCI) was used to probe for structural defects in the Cd₃As₂ epilayers [13]. Images were taken in the Cd_3As_2 ($\bar{4}08$)/($\bar{4}40$) channeling condition to characterize threading dislocation defect populations and other extended defects.

III. RESULTS

We first discuss the properties of the lattice-engineered II-VI buffer layers, as they will affect the Cd₃As₂ morphology and electron mobility. Figure 1 shows x-ray diffraction (XRD) scans, reflection high-energy electron diffraction (RHEED) patterns, and atomic force microscopy (AFM) scans from typical buffer structures. All buffers started with a ZnTe epilayer (7.3% mismatch with GaAs), grown directly on

on-axis GaAs(111) using a Zn treatment prior to growth to maximize the ZnTe crystalline quality [14]. Growth using a VI/II ratio of 2:1 (total absolute beam flux of 3×10^{-7} Torr), a substrate temperature of 330 °C, and broadband illumination at a lamp power of 100 W produced the smoothest films and highest-intensity thickness fringes in XRD [Fig. 1(a)], consistent with sharp interfaces. Stoichiometric or group II rich growths resulted in very spotty RHEED patterns (not shown). Growing these epilayers thicker than 25 nm was also found to result in rougher morphologies. After ZnTe, a final Zn_xCd_{1-x} Te epilayer was grown. For the extreme endpoint of CdTe, an approximately 150-nm layer was grown on the relaxed ZnTe surface under similar flux conditions at a lower substrate temperature (~ 240 °C), resulting in film roughnesses comparable to the starting GaAs layers. Zn_xCd_{1-x}Te epilayers of mixed composition were grown at intermediate temperatures depending upon the relative Zn and Cd content. For instance, a Cd/Zn beam flux ratio of \sim 2 : 1 and a substrate temperature of 290 °C were used to achieve a lattice matching composition ($Zn_{0.42}Cd_{0.58}Te$) to the Cd_3As_2 epilayer.

We next discuss the properties of the Cd_3As_2 epilayers grown on these II-VI buffers. Table I summarizes the impact of the buffer composition, substrate miscut, and broadband illumination on the Cd_3As_2 electron mobility. Cd_3As_2 growth was performed at substrate temperatures of approximately $100{\text -}120\,^{\circ}\text{C}$ under As_4 rich conditions and combined absolute fluxes of $5{\text -}8 \times 10^{-7}\,\text{Torr}$. These low temperatures are required due to the high vapor pressure of Cd_3As_2 [15]. Slightly higher substrate temperatures were previously found to produce higher electron mobilities, where a nearly twofold increase was observed when raising the temperature from 140 to $210\,^{\circ}\text{C}$ [10]. However, these temperatures also require high flux rates to overcome an elevated Cd_3As_2 decomposition, so we therefore utilized much lower temperatures that are more practical for growth. All growths under illumination

Growth condition			Electron mobility
Substrate miscut	II-VI buffer	Illumination	$(cm^2/V s)$
On axis	CdTe	Dark	2000–4000
On axis	CdTe	Illuminated	4000-5000
On axis	$Zn_{0.42}Cd_{0.58}Te$	Illuminated	4500-6000
3° miscut	CdTe or ZnTe	Illuminated	7000–9000
3° miscut	$Zn_{0.42}Cd_{0.58}Te$	Dark	7000-8000
3° miscut	$Zn_{0.42}Cd_{0.58}Te$	Illuminated	13 000–15 000

TABLE I. Summary of Cd₃As₂ electron mobility based on substrate, buffer, and growth conditions.

conditions were carried out with a Xe lamp setting of 100 W except in the power-dependence study discussed later.

Figure 1(e) shows RHEED and AFM results from Cd₃As₂ epilayers grown on a lattice-mismatched CdTe-terminated buffer on an on-axis GaAs substrate. CdTe layers showed smoother morphologies and narrower diffraction peaks than ZnTe and also allows for comparison with previous reports [10,16]. A $4\times$ reconstruction is observed parallel to the $[0\bar{1}1]$ and $[\bar{2}11]$ directions [relative to GaAs(111)]. A smooth transition between the II-VI and Cd₃As₂ is observed, with no evidence of roughening during film nucleation. Previous reports have not discussed the surface reconstruction explicitly, but published images appear to show faint 4× streaks [10,16]. The lattice parameters of unstrained Cd₃As₂ epilayers on lattice-matched Zn_xCd_{1-x} Te buffers, as measured by XRD [Fig. 1(a)] are in good agreement with reported values, as shown in Fig. 1(a) on a lattice-matched buffer layer, while AFM revealed two-dimensional (2D) but rough morphologies relative to the underlying layers (\sim 2–3 nm rms roughness). Epilayer thicknesses were not directly measured, but x-ray reflectivity performed on thinner samples suggests the Cd₃As₂ epilayers presented here were approximately 200-250 nm thick. Baseline Cd₃As₂ epilayers grown under dark conditions on on-axis substrates with lattice-mismatched CdTe buffers exhibit low electron mobilities $\sim 2000-4000 \,\mathrm{cm}^2/\mathrm{V}\,\mathrm{s}$. The electron mobilities improved to 4000–5000 cm²/V s when broadband illumination was applied. All films, regardless of the illumination conditions, had sheet carrier concentrations of $3-6 \times 10^{13}$ cm⁻², which corresponds to $1-3 \times 10^{18}$ cm⁻³ given the approximate film thicknesses.

Previous reports showed mild twinning arising at the Cd₃As₂ interface [10,11]. Twinning is also a known issue in CdTe epilayers [17]. Figure 2 displays phi scans of the (4416) peaks of Cd_3As_2 grown on $Zn_xCd_{1-x}Te$ buffers. The sixfold symmetry of these peaks arises from the 180° rotations that occur during twinning. Similar degrees of twinning are observed in both Cd_3As_2 layers (red curve) and $Zn_xCd_{1-x}Te$ layers across the entire solid solution grown on on-axis substrates (not shown), suggesting twinning is largely initiated in the buffer layers and then propagates throughout the structure. Twinning was substantially reduced by performing growths under similar conditions on wafers 3° miscut toward $(2\overline{1}\overline{1})$, shown in Fig. 2, similar to previous reports [11]. In particular, little evidence of twins (1% or less) was observed in both the Cd₃As₂ (blue curve) or Zn_{0.42}Cd_{0.58}Te layers (not shown) with nearly lattice-matched compositions.

Figure 3 summarizes the impact of the II-VI buffer lattice constant on the Cd_3As_2 properties. Reciprocal space

maps [Figs. 3(a)–3(c)] confirm that the Cd₃As₂ epilayers are highly relaxed on 3° miscut CdTe (2.3% mismatch) and ZnTe (-3.4% mismatch) buffers, while Cd₃As₂ grown on Zn_{0.42}Cd_{0.58}Te buffers appeared nearly lattice matched with narrower peak shapes. No significant mobility difference is observed between epilayers grown on either ZnTe and CdTe buffers [Figs. 3(d) and 3(f)], despite the lower Cd₃As₂ surface roughness on CdTe. This suggests that morphology only plays a minor role in limiting the electron mobility compared to other defects, which is consistent with previous reports [10].

To evaluate the influence of the II-VI buffer lattice constant on extended defects in Cd₃As₂, we performed ECCI measurements on Cd₃As₂ epilayers grown on all three buffers. The micrographs [Fig. 3(d)-3(i)] indicate that the epilayers have similar threading dislocation densities (TDDs) of \sim 4–8 \times 10⁸ cm⁻²; however, there appears to be a substantial reduction in the density of other extended defects in the epilayers grown on lattice-matched Zn_xCd_{1-x} Te buffers compared to those grown on lattice-mismatched ZnTe and CdTe buffers. Figure 4 highlights the two major differences observed in unstrained and relaxed Cd₃As₂. The former is more structurally homogeneous but does show signs of pitting at the film surface, as seen in the AFM micrograph presented in Fig. 4(a). The latter shows regions of structural defects, such as the boundary highlighted in Fig. 4(b). These types of defective regions are only observed in relaxed Cd₃As₂ films. Although

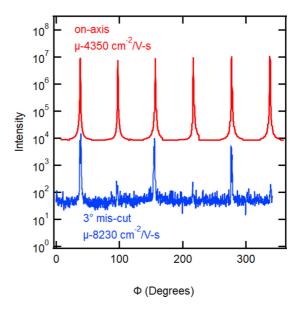


FIG. 2. Phi scans of Cd_3As_2 (44<u>16</u>) peaks grown on $Zn_xCd_{1-x}Te/ZnTe$ buffers with and without a substrate offcut.

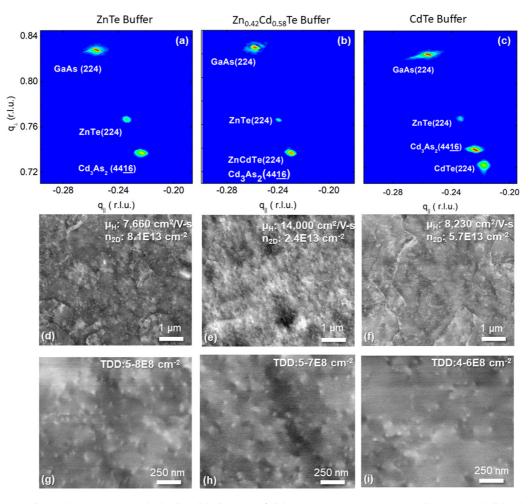


FIG. 3. (a)–(c) Reciprocal space maps and (d)–(i) ECCI images of Cd_3As_2 grown on ZnTe, $Zn_{0.42}Cd_{0.58}Te$, and CdTe buffer structures. Electron mobility and sheet density from room-temperature Hall measurements are noted in the middle panels. Measured TDDs from the ECCI images are noted in the bottom panels.

we are still exploring the origin of these differences, removing the lattice mismatch between the buffer and epilayer appears to help suppress the formation of certain types of extended defects.

Suppression of extended defects has a substantial effect on the electron mobility. When twinning is reduced through the use of a miscut substrate but a lattice-mismatched

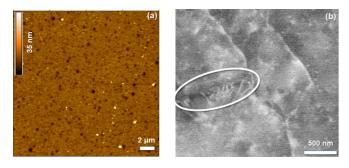
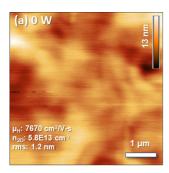
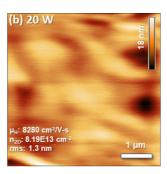


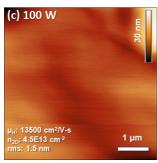
FIG. 4. (a) AFM image of Cd_3As_2 grown on $Zn_{0.42}Cd_{0.58}Te$ from Fig. 3(e) showing the existence of pitting and (b) magnified region of the ECCI image in Fig. 3(f) highlighting a region of structural inhomogenity observed throughout relaxed Cd_3As_2 grown on CdTe or ZnTe buffer layers.

CdTe or ZnTe buffer is used, the electron mobility improves to $7000-9000\,\mathrm{cm^2/V}\,\mathrm{s}$. The addition of a lattice-matched $\mathrm{Zn_{0.42}Cd_{0.58}Te}$ buffer further increases the mobility to $13\,000-15\,000\,\mathrm{cm^2/V}\,\mathrm{s}$. These values are close to the highest reported room-temperature values for epitaxially grown thin films ($19\,300\,\mathrm{cm^2/V}\,\mathrm{s}\,[10]$).

Given the previous success broadband illumination of the growth surface has had on improving the optical properties of II-VI semiconductors grown at low temperature [18], we explore it as a tool for further improving epitaxial Cd₃As₂. All epilayers discussed up to this point were grown under broadband illumination with 100-W power. Figure 5 details the impact of Xe lamp power on the electron mobility and surface morphology of Cd₃As₂ epilayers grown on latticematched, miscut Zn_{0.42}Cd_{0.58}Te buffers. While the film morphology became rougher with increasing illumination, the electron mobility increased up to intermediate lamp powers of 100 W. Illumination of semiconductor surfaces during growth has been demonstrated to reduce point defects, which is likely a particular concern here due to the low substrate temperatures used for Cd₃As₂ growth. Light has previously been found to affect semiconductor growth by increasing adatom desorption [19], altering surface kinetics [20], and modifying defect formation [21]. Changes in surface kinetics under illumination







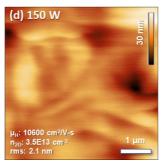


FIG. 5. AFM images and measured room-temperature electron mobilities and rms roughnesses of Cd_3As_2 films under (a) 0 W, (b) 20 W, (c) 100 W, and (d) 150 W UV lamp illumination. Values correspond to UV lamp power.

could also be responsible for the surface roughening [22]. Both Cd and As have nonunity sticking coefficients, so it is possible the net result of illumination on this surface is more Cd and/or As desorption. Reduction in defects by light stimulation would cause an increase in the electron mobility, although the exact pathways and the specific defect population affected have not been identified at this time. Further investigation is required to understand the underlying mechanisms of both trends in this material system. However, we reiterate the point that broadband light stimulation is found to be a key method for producing room-temperature electron mobilities >13 000 cm²/V s at growth temperatures below 170 °C.

While improvements in Cd_3As_2 electron mobility were gained through the use of lattice-matched II-VI buffers, miscut substrates, or broadband illumination, only a combination of the three produced electron mobilities above $10\,000\,\mathrm{cm^2/V}\,\mathrm{s}$. Consistent with Matthiessen's rule, our results illustrate that reducing the density of one type of defect can only improve the electron mobility of Cd_3As_2 so much when relatively large densities of others exist. For example, this rule is evident in the magnitude of the improvement produced by broadband light illumination. When growth is carried out on on-axis substrates and lattice-mismatched buffers, illumination only increased the electron mobility by $\sim 1000\,\mathrm{cm^2/V}\,\mathrm{s}$, suggesting the mobility is dominated by extended defects. However, when illumination was applied to growth on miscut substrates and lattice-matched

Zn_{0.42}Cd_{0.58}Te buffers, illumination produced a 5000 cm²/Vs increase. This result suggests that illumination affects some additional type of defect population beyond dislocations and twin defects. On the whole, the systematic comparison of growth conditions, defect types, and the resulting electron mobilities provides some guidance on the extent to which different defect populations affect the electron mobility and which ones must be targeted to realize improvements.

Our study indicates that multiple types of defects substantially contribute to the low electron mobilities in epitaxially grown Cd_3As_2 compared to high-quality bulk single crystals $(42\,850\,\text{cm}^2/\text{V}\,\text{s}\,[23])$. We suggest the following strategies to realize further gains. The dislocation densities in our Cd_3As_2 epilayers ($\sim 10^8\,\text{cm}^{-2}$) are still quite high and will need to be reduced through better design of the II-VI buffers. Disorder and point defects can be reduced through annealing above the practical growth temperatures used here with a sufficiently stable capping layer [24]. The role of the II/V ratio must also be explored to obtain additional insight into the role of Cd or As vacancies (and other native defects) on the electron mobilities. However, the higher symmetry of the zinc-blende structure will ultimately be a limiting factor at some point.

IV. CONCLUSIONS

In summary, we demonstrate a II-VI platform providing tunable lattice constants and smooth morphologies for Cd_3As_2 growth. Controlling defects using miscut substrates, lattice-matched buffer layers, and broadband illumination produced higher electron mobilities while maintaining lower growth temperatures to limit Cd_3As_2 decomposition. Our results provide insight into the types of defects formed within epitaxial Cd_3As_2 and their influence on the transport properties. Such studies are needed as we push the limits of epitaxial crystal quality to enable new-physics discoveries within the Cd_3As_2 material system and utilize it for future technological advances.

ACKNOWLEDGMENTS

This work was authored in part by employees of the Alliance for Sustainable Energy, LLC, the Manager and Operator of the National Renewable Energy Laboratory for the US Department of Energy (DOE) under Contract No. DE-AC36-08GO28308. Funding was provided by the Laboratory Directed Research and Development program. The views expressed in the article do not necessarily represent the views of the DOE or the US Government. The US Government retains and the publisher, by accepting the article for publication, acknowledges that the US Government retains a nonexclusive, paid-up, irrevocable, worldwide license to publish or reproduce the published form of this work, or allow others to do so, for US Government purposes.

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